



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Katsuto TANAHASHI et al.**

Group Art Unit: **3663**

Application Number: **10/743,793**

Examiner: **Johannes P. Mondt**

Filed: **December 24, 2003**

Confirmation Number: **9788**

For: **SEMICONDUCTOR SUBSTRATE AND MANUFACTURING
METHOD THEREOF**

Attorney Docket Number: **032206**
Customer Number: **38834**

RESPONSE UNDER 37 C.F.R. § 1.111

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

May 3, 2006

Sir:

In response to the Office Action dated January 4, 2006, the response date of which having been extended by one month to May 4, 2006, Applicants submit the following remarks, which begin on page 2 of this paper.